

FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE				ATTY. DOCKET NO. ARC9-2000-0066-US2		SERIAL NO. <u>10/765</u> <del>Not yet assigned</del> <u>545</u>	
<b>LIST OF PRIOR ART CITED BY APPLICANT</b> (Use several sheets if necessary)				APPLICANT BAGLIN, John E.E.			
				FILING DATE Filed Herewith		GROUP not yet assigned	
<b>U.S. PATENT DOCUMENTS</b>							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A	5 0 7 9 6 6 2	01/07/92	<del>Kawakami et al.</del>			
		5 5 5 0 1 0 1	08/27/96	Nagata et al.			
		6 0 7 7 6 1 8	06/20/00	Sakamina et al.			
		6 3 1 7 3 0 2	11/13/01	Van Kesteren et al.			
<b>FOREIGN PATENT DOCUMENTS</b>							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
<b>OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)</b>							
AKS	B	Yimin Guo et al. in "Low Fringe-Field and Narrow-Track MR Heads", IEEE Transactions on Magnetics, Vol. 33, No. 5, Sept. 1997, pp. 2827-9.					
AKS	C	G.J. Athas et al. "Focused Ion Beam System for Automated MEMS Prototyping and Processing", Proc. SPIE - Int. Soc. Opt. Eng. (USA), Vol. 3223, 1997, pp. 198-207.					
AKS	D	Charles Partee et al., "Off-Track Response Versus Shield Width at the ABS for MR Heads", IEEE Transactions on Magnetics (USA), Vol. 33, No. 5, Pt. 1, Sept. 1997, pp. 2887-9.					
AKS	E	W.M. Kaminsky et al., "Patterning Ferromagnetism in Ni <sub>80</sub> Fe <sub>20</sub> Films via 30 keV Ga <sup>+</sup> on Irradiation", Applied Physics Letters, March 30 2000.					
EXAMINER <u>Asok Kumar Sankaran</u>				DATE CONSIDERED <u>12/21/2004</u>			
* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							